Docket No.: 202450US0

IN THE WITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED OCT 16 2003 TC 1700

IN RE APPLICATION OF: Atsushi SHIOTA, et al.

SERIAL NO:

09 770,289

GAU:

1712

FILED:

January 29, 2001

EXAMINER: M. FEELY

FOR:

PROCESS FOR PRODUCING SILICA-BASED FILM, SILICA-BASED FILM, INSULATING FILM,

AND SEMICONDUCTOR DEVICE

REQUEST FOR CONTINUED EXAMINATION (RCE) TRANSMITTAL

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

This is a request for Continued Examination (RCE) under 37 C.F.R. §1.114 of the above-identified application.

Submission required under 37 C.F.R. §1.114

Enclosed:

Amendment/Reply w/Attachment (13 pp.)

■ Information Disclosure Statement (IDS)

Other: Declaration Under 37 C.F.R. §1.131 w/Attachments (8 pp., executed)

Supplemental Declaration (3 pp., executed)

Form PTO-1449 Cited References (13)

FEES	RATE	CALCULATIONS
Suspension of action on the above-identified application is requested under 37 C.F.R. §1.103(c) for a period of months.	\$130.00	\$0.00
RCE Fee required under 37 C.F.R. §1.17(e)	\$770.00	\$770.00
		\$0.00
		\$0.00
TOTAL OF ABOVE CALC	ULATIONS:	\$770.00
☐ REDUCTION BY 50% FOR FILING AS SMALL ENTITY		\$0.00
	TOTAL:	\$770.00

- A check in the amount of \$770.00 is enclosed
- Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 CFR 1.136, and any additional fees required under 37 CFR 1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,

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